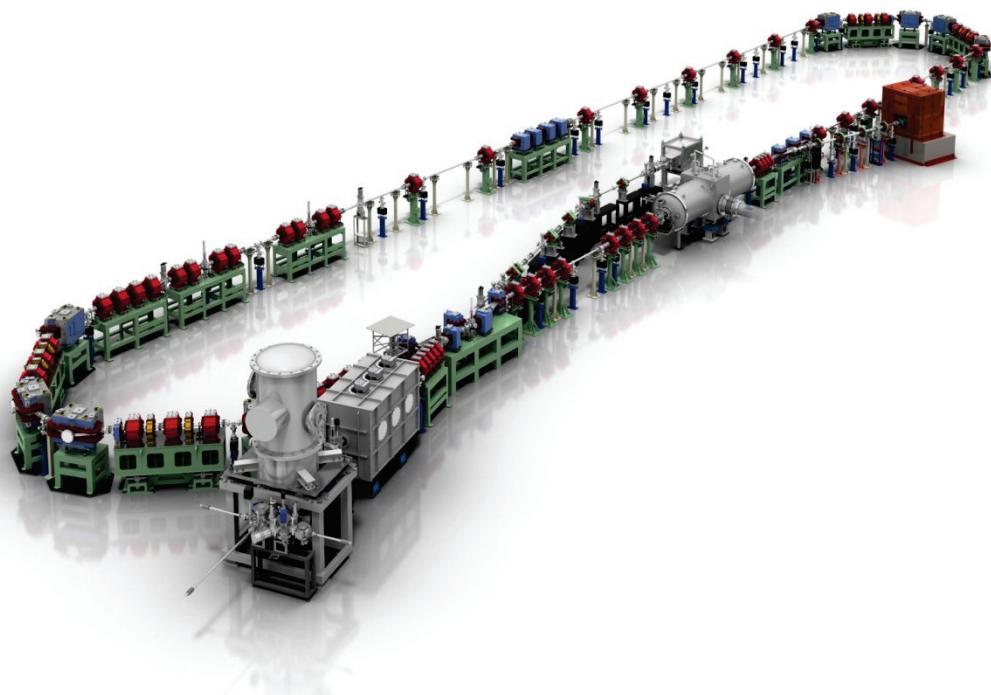




Performance of the Digital LLRF Systems for cERL at KEK

Feng QIU (KEK) June 10, 2015



Main Content

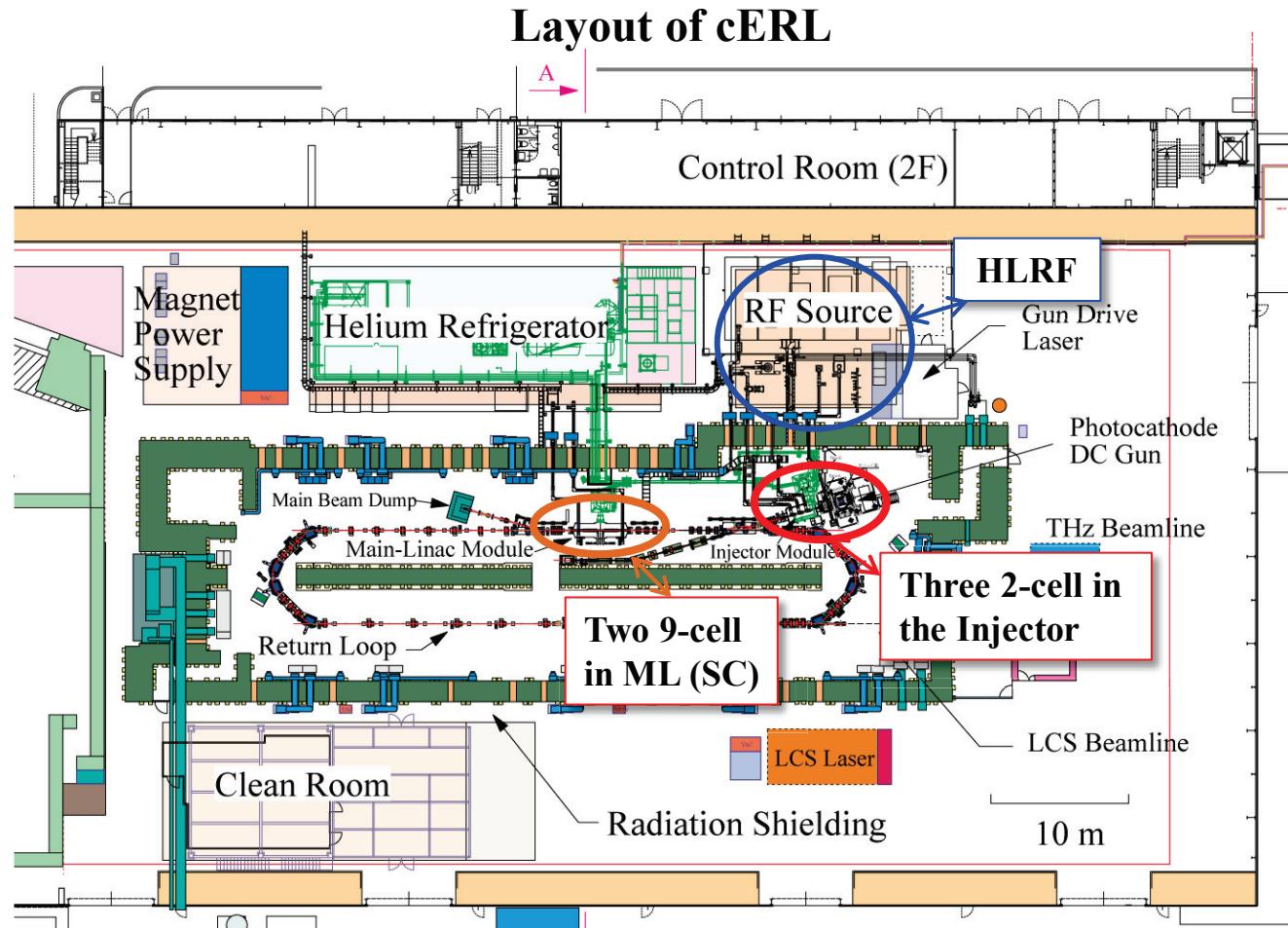
- Introduction
- High Level RF system
- Low Level RF system
- Performance
- Disturbances in RF system
- Adaptive feedforward control
- Summary

Introduction

- Compact ERL (cERL) is a test facility for the future 3-GeV ERL project. It is a 1.3-GHz superconducting system and is operated in CW mode.

Injector consists of four cavities: Buncher (NC), Injector 1 (SC), Injector 2 (SC), Injector 3 (SC).

Main linac includes two nine-cell cavities (SC).



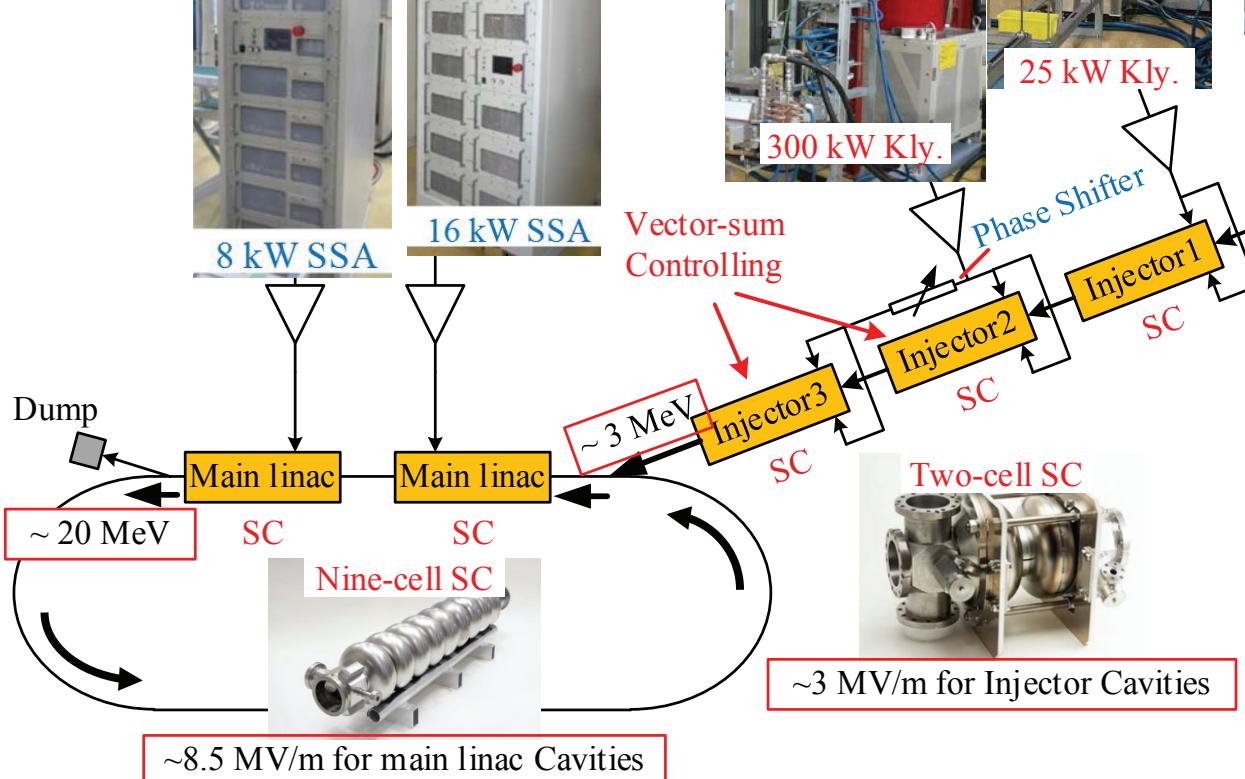
- April, 2013, injector commissioning. Oct. 2013, main linac commissioning.

HLRF (Power Source)

- At present, total four kinds of Power Sources are applied in cERL : 8-kW SSA, 16-kW SSA, 25-kW Klystron and 300 kW Klystron.

RF requirement

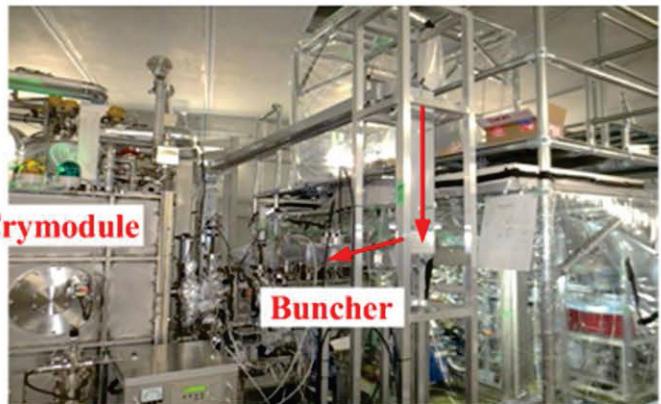
0.1 % rms, 0.1 deg. rms for cERL
0.01% rms, 0.01deg.rms for 3GeV-ERL



8 kW SSA

Cavity	QL	RF power
Bun.	1.1e5	3 kW
Inj. 1	1.2e6	0.53 kW
Inj. 2	5.8e5	2.4 kW
Inj. 3	4.8e5	
ML1	1.3e7	1.6 kW
ML2	1.0e7	2 kW

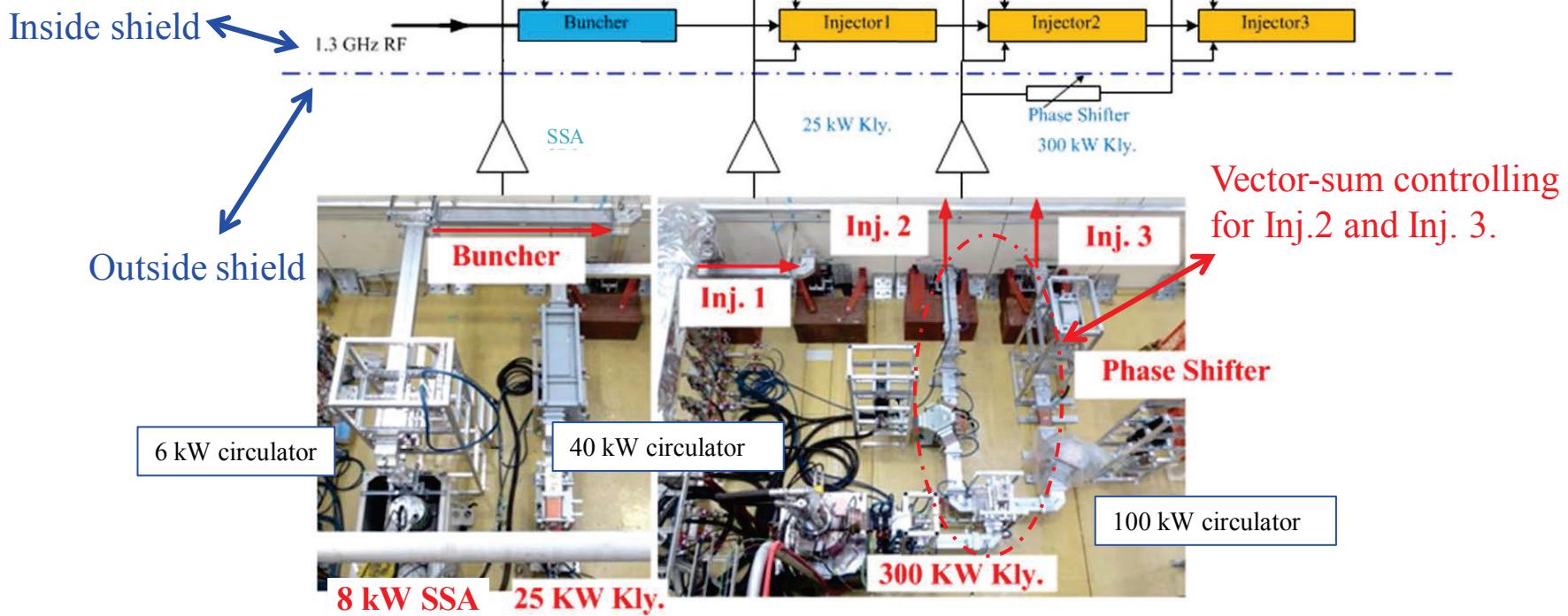
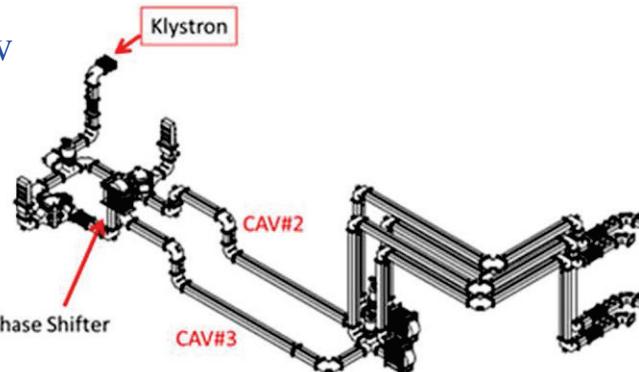
HLRF (Power Distribution System)



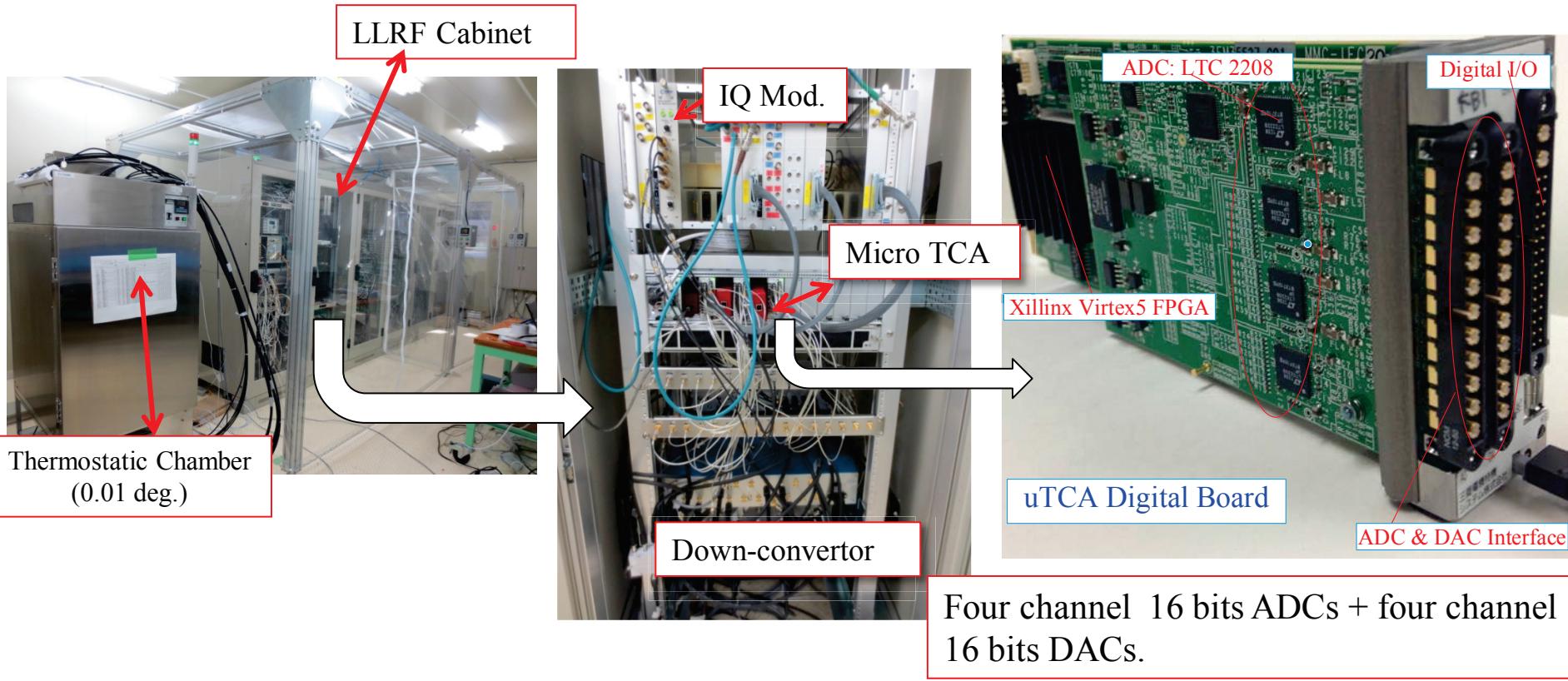
Cryomodule

Buncher

Rather narrow
space and
complicated
waveguide.



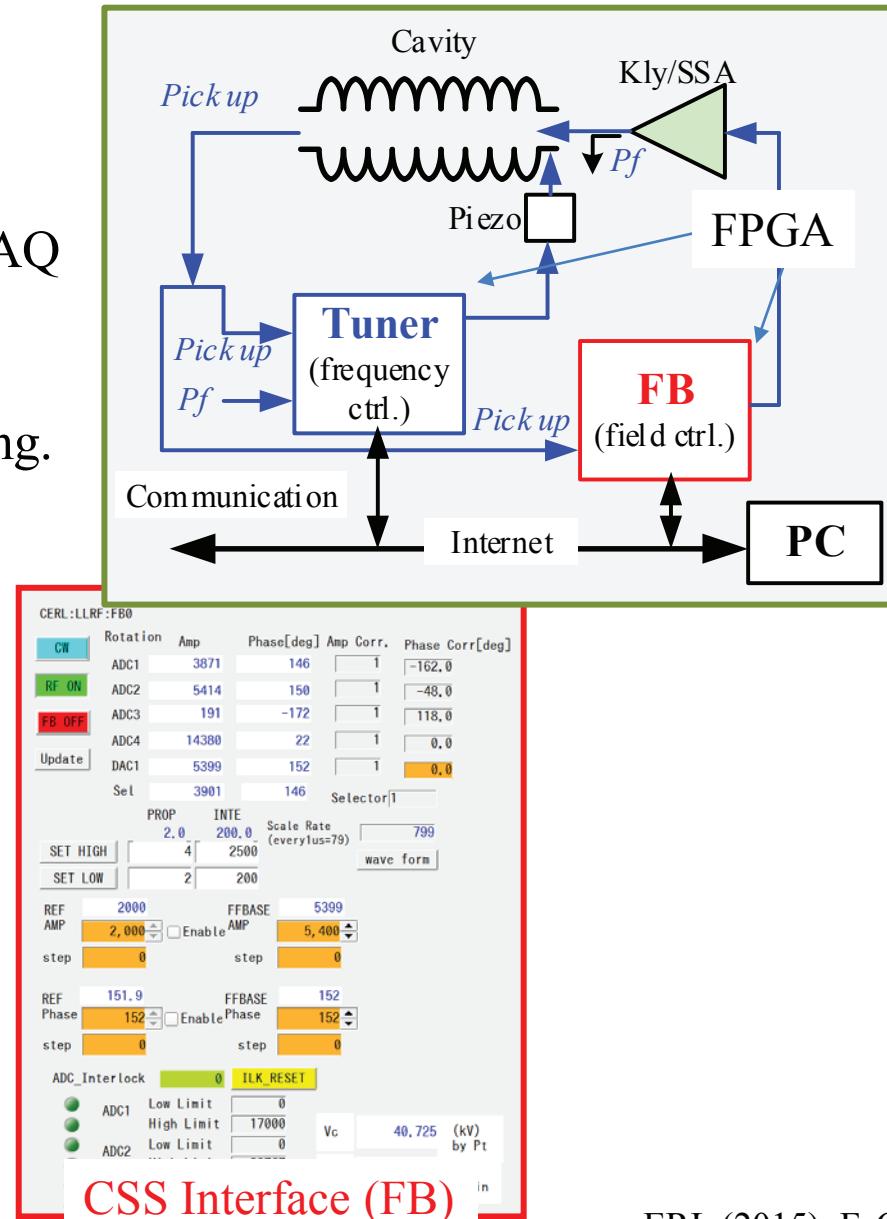
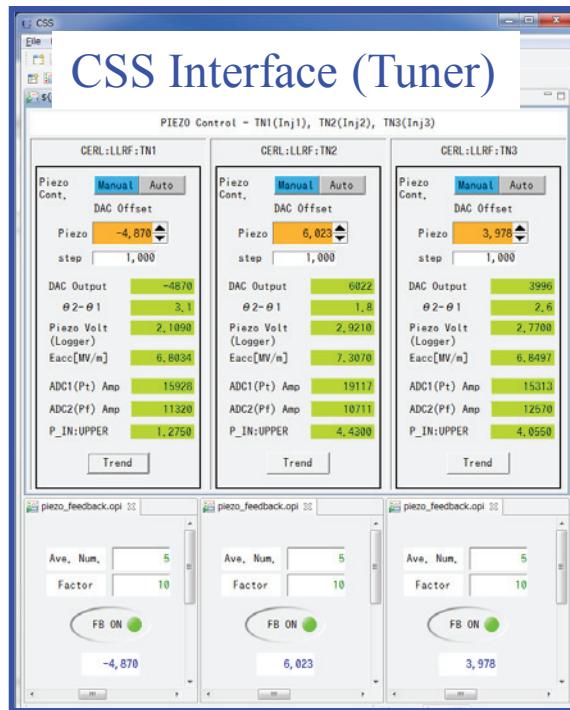
LLRF (Digital Board)



Digital Board	type	Feature
ADC	LTC2208	16 bits, 130 MHz (Max.)
DAC	AD9783	16 bits, 500 MHz (Max.)
FPGA	Virtex 5 FX	550 MHz (Max.), includes a Power PC with Linux, EPICS is installed on the Linux.

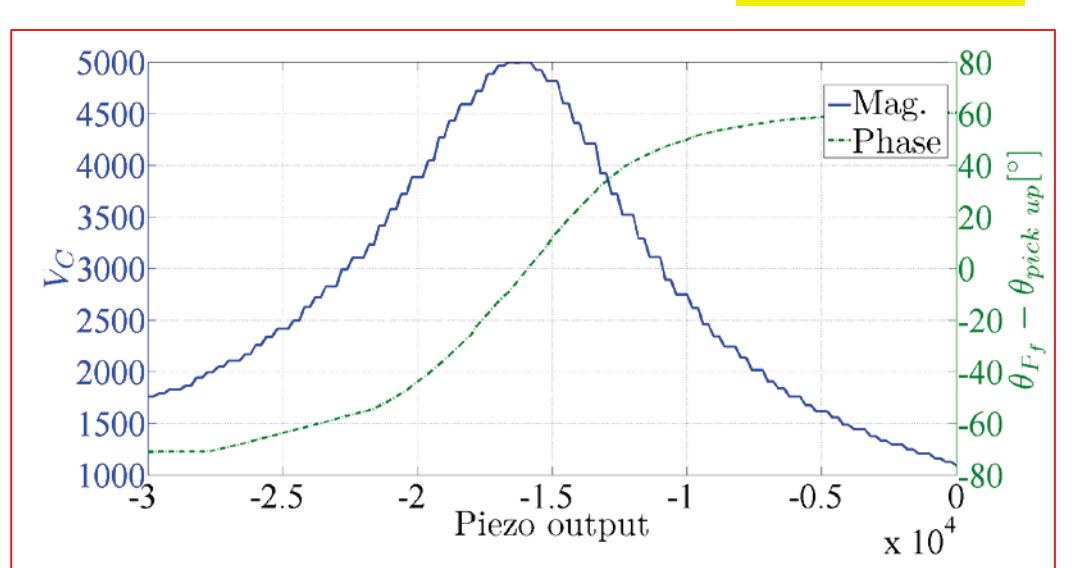
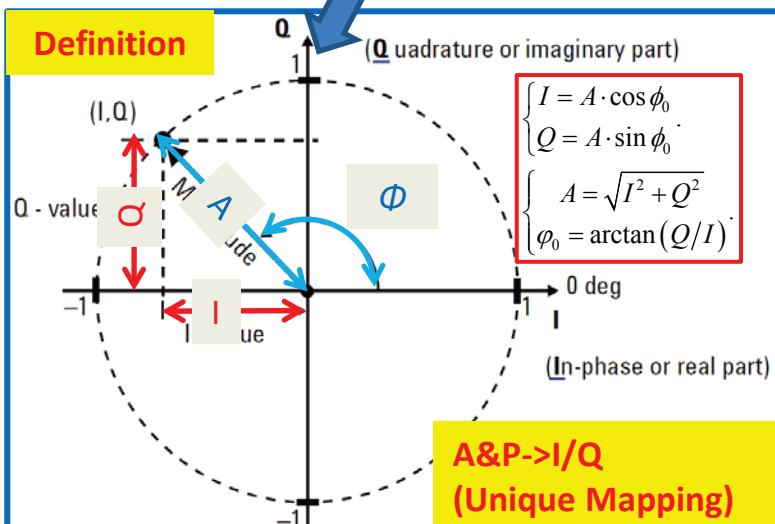
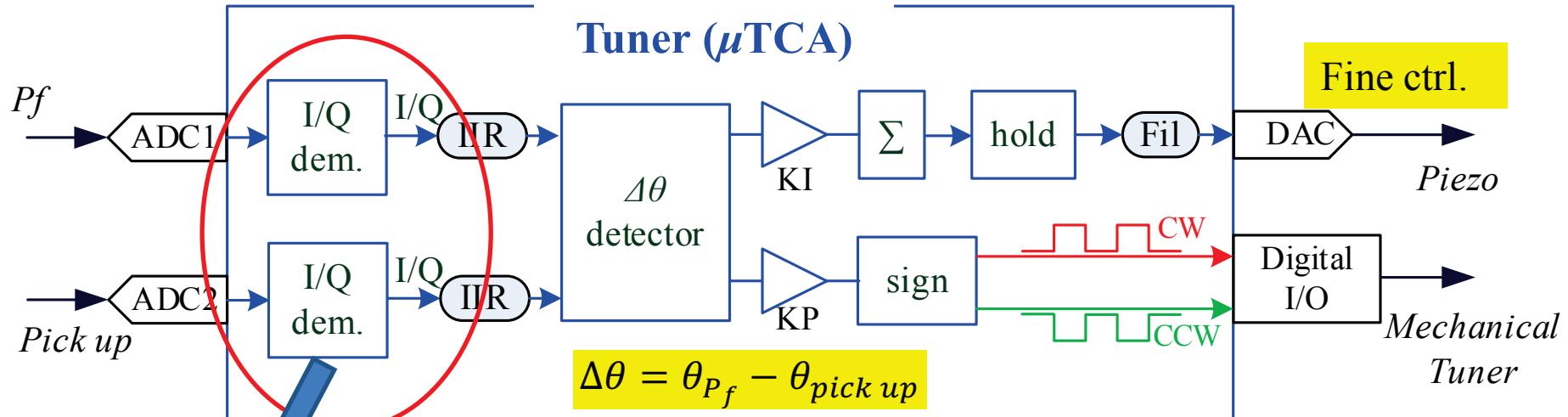
LLRF (DAQ & communication)

- LLRF (Tuner + FB)
- EPICS (Experimental Physics and Industrial Control System) is installed inside Micro TCA and is used as the DAQ (data acquisition) system.
- CSS (Control System Studio) is in charge of the user interface programming.

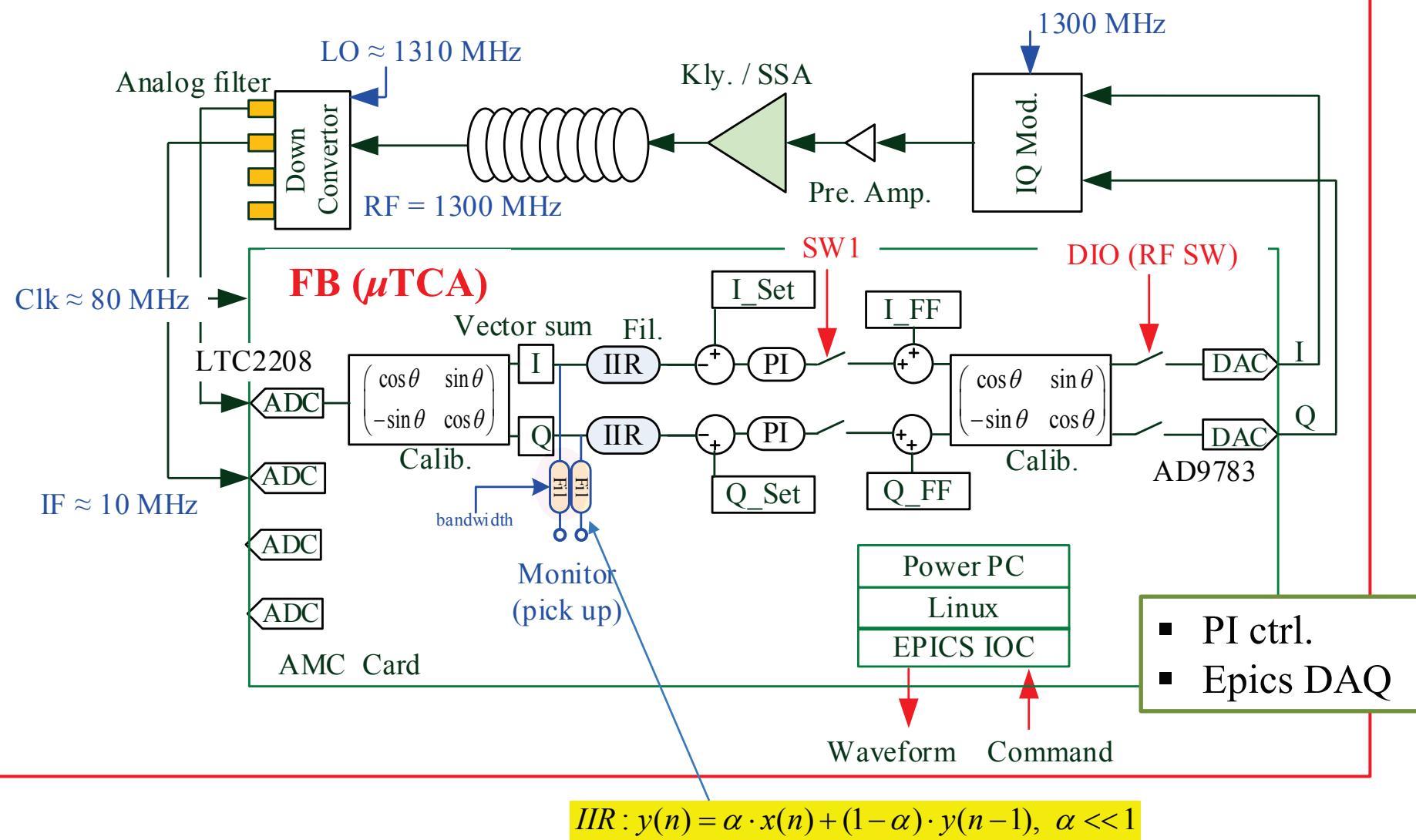


LLRF (frequency control)

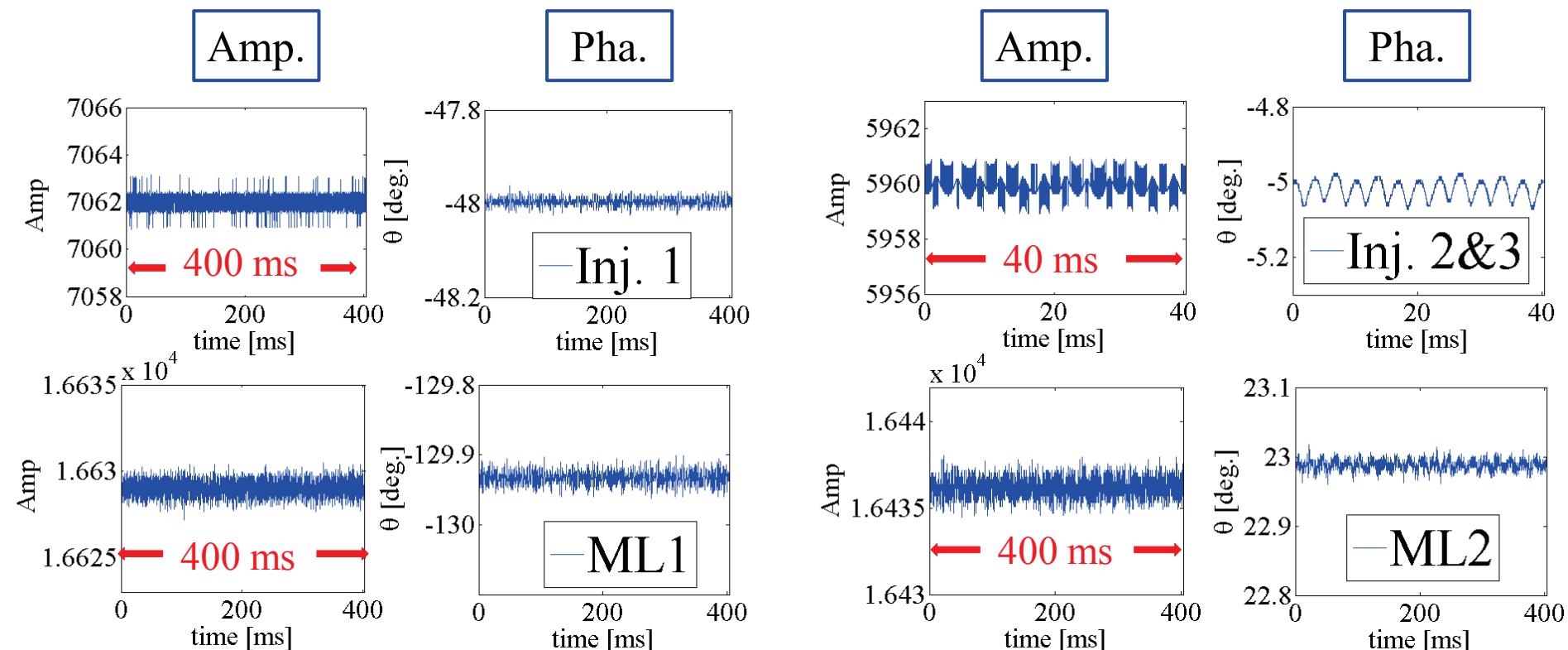
- Cavity resonance frequency control: Tuner + Piezo.



LLRF (field control)



Current Performance (RF field)



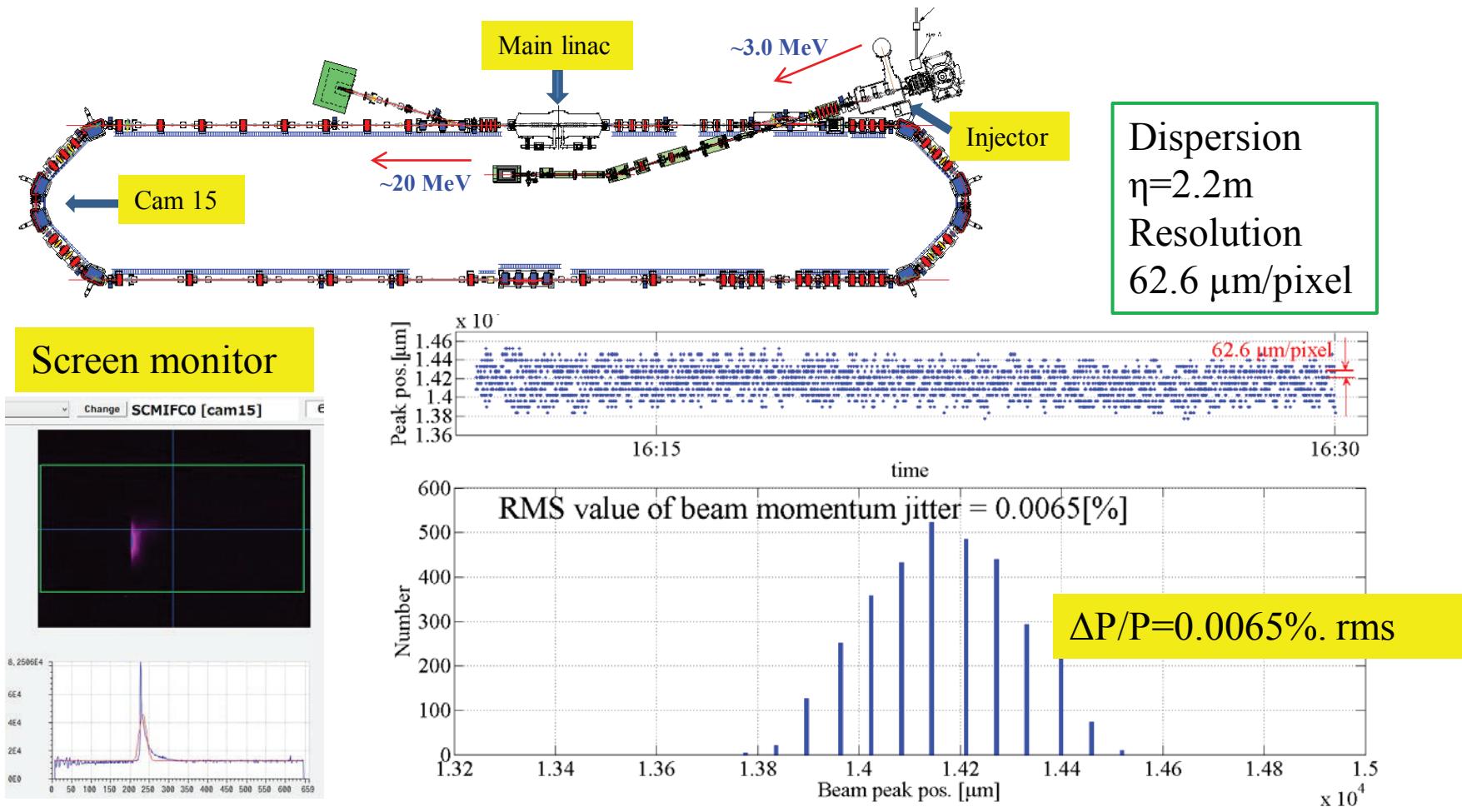
RF stability	Bun.	Inj. 1	Inj. 2&3 (VS)	ML1	ML2
$\Delta A/A [\%, \text{rms}]$	0.07%	0.006%	0.007%	0.003%	0.003%
$\Delta \theta [^\circ, \text{rms}]$	0.04°	0.009°	0.025°	0.010°	0.007°



Beam Momentum jitter is 0.006% (in agreement)

Performance (Beam energy)

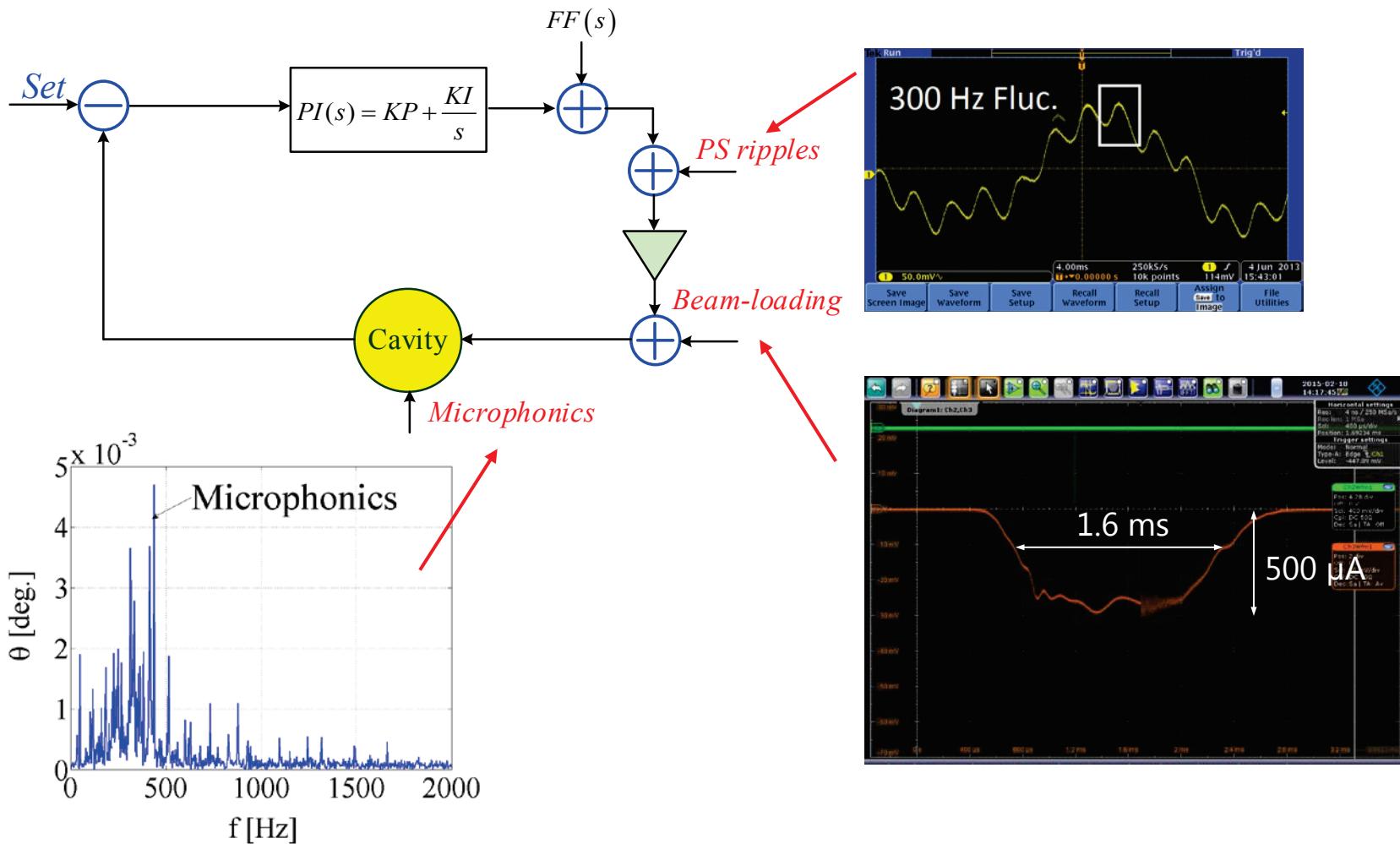
- Beam momentum jitter is measured by screen monitor and determined by the peak point of the projection of the screen.



R&D (Adaptive FF)

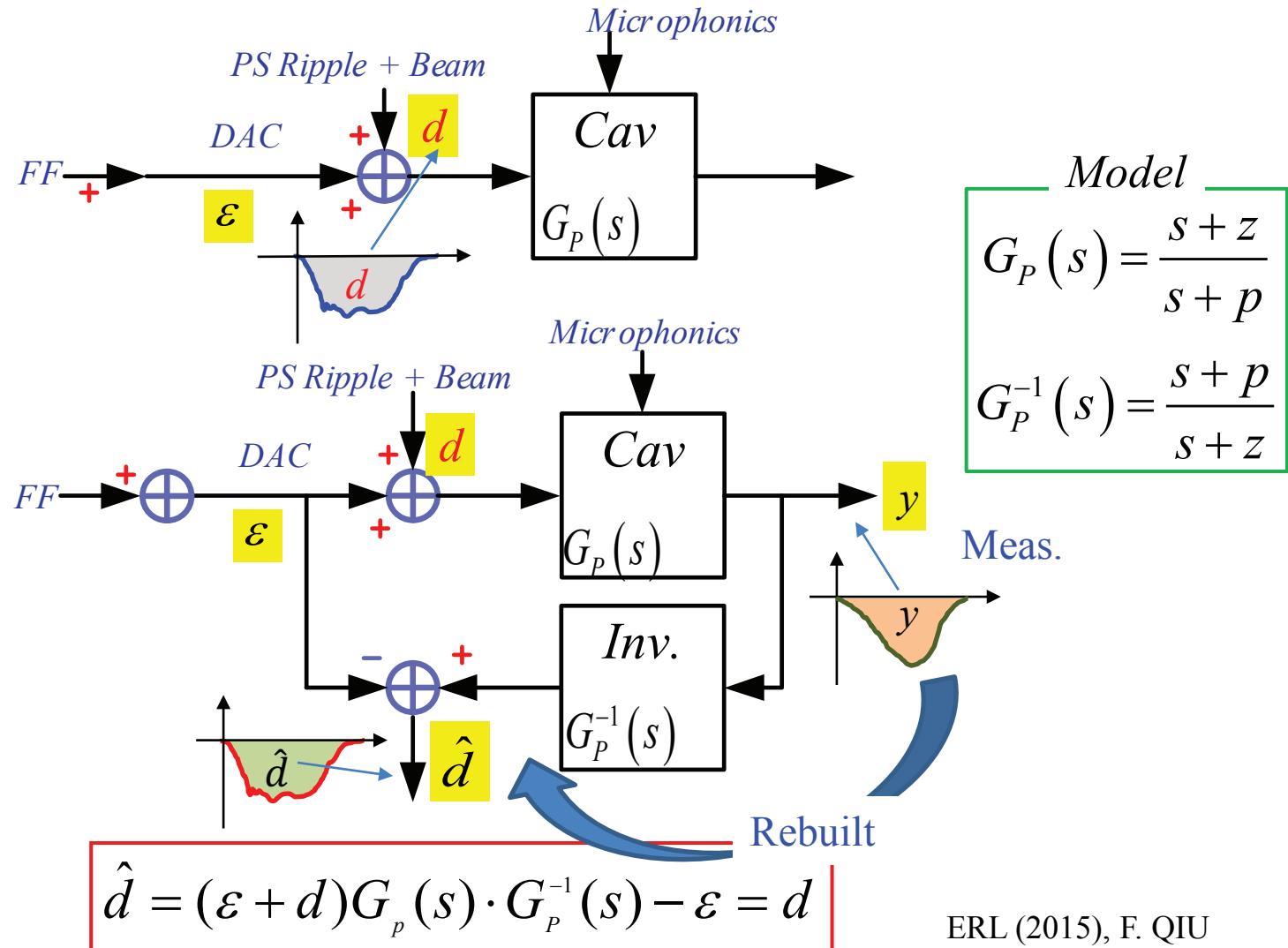
Disturbances in RF system

- Main disturbances: High voltage power supply ripples (300 Hz) + burst mode beam-loading (0.5 mA~1mA, 1 ms ~ 2 ms) and Microphonics (DC ~ 500 Hz).



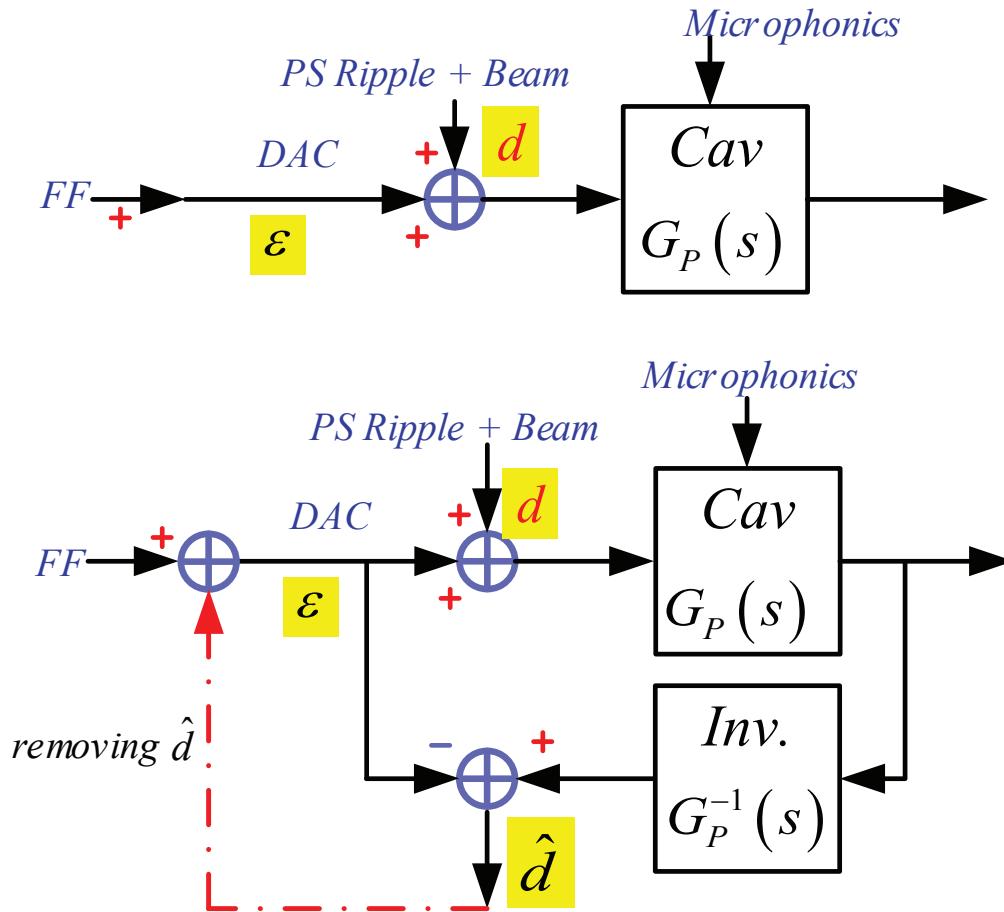
Adaptive FF ctrl

- The disturbances estimate \hat{d} can be evaluated accurately if we “know” the mathematical model of the system (disturbance observer).
- Disturbance-Observer-Based control (DOB control)



Adaptive FF ctrl (cont'd)

- The disturbances estimate \hat{d} can be removed from FF table, thus the disturbance signal d is rejected.



$$\hat{d} = (\varepsilon + d)G_p(s) \cdot G_P^{-1}(s) - \varepsilon = d$$

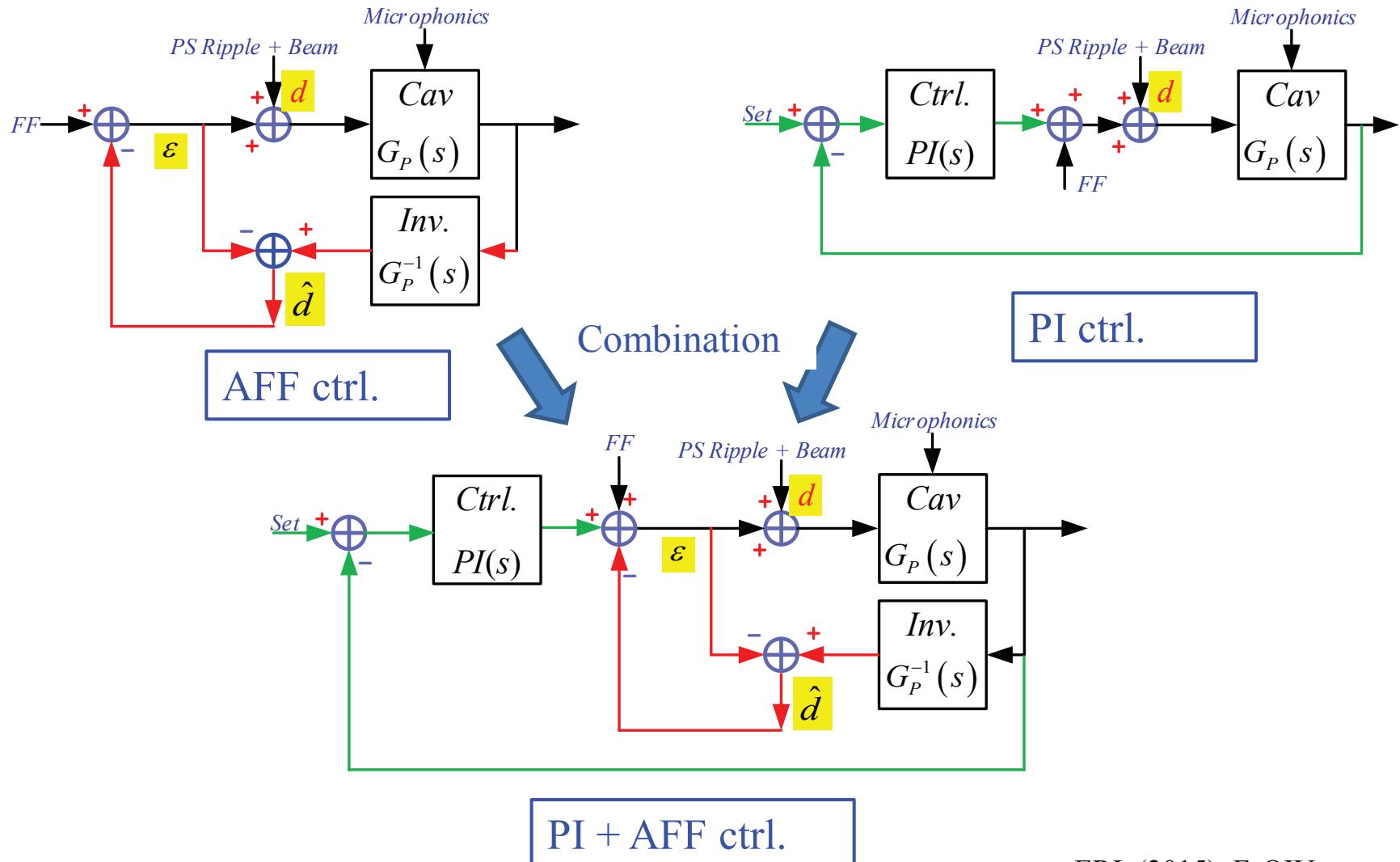
Model

$$G_P(s) = \frac{s+z}{s+p}$$

$$G_P^{-1}(s) = \frac{s+p}{s+z}$$

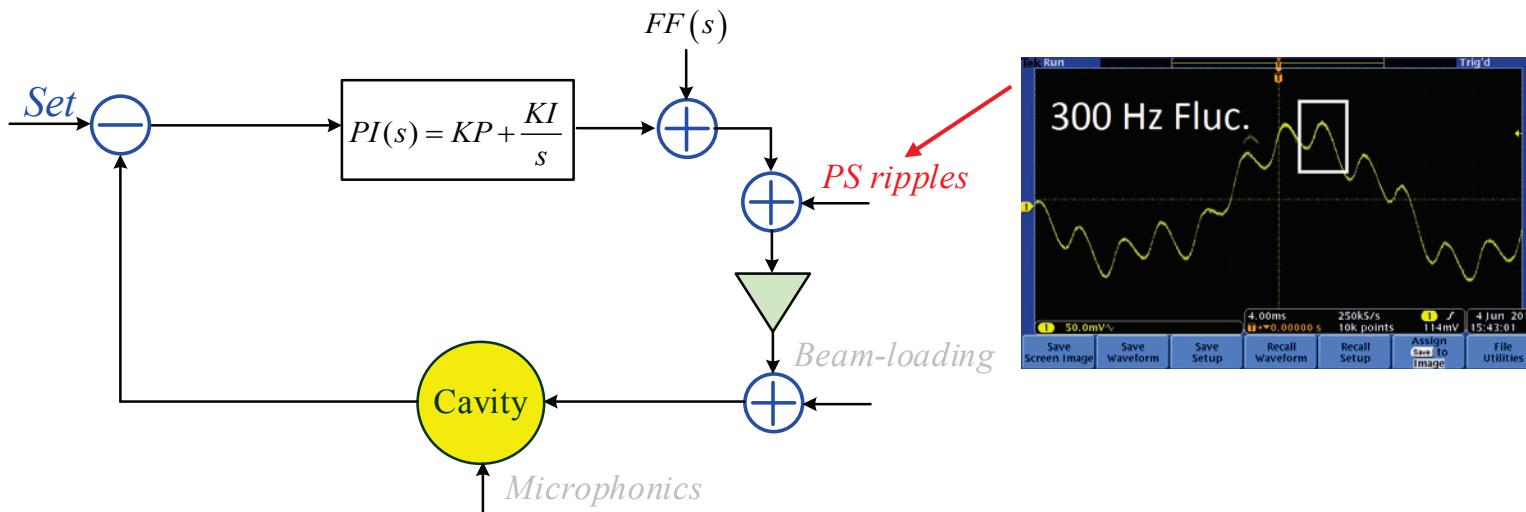
Adaptive FF ctrl (cont'd)

- In practical, the combination of AFF control and PI control.



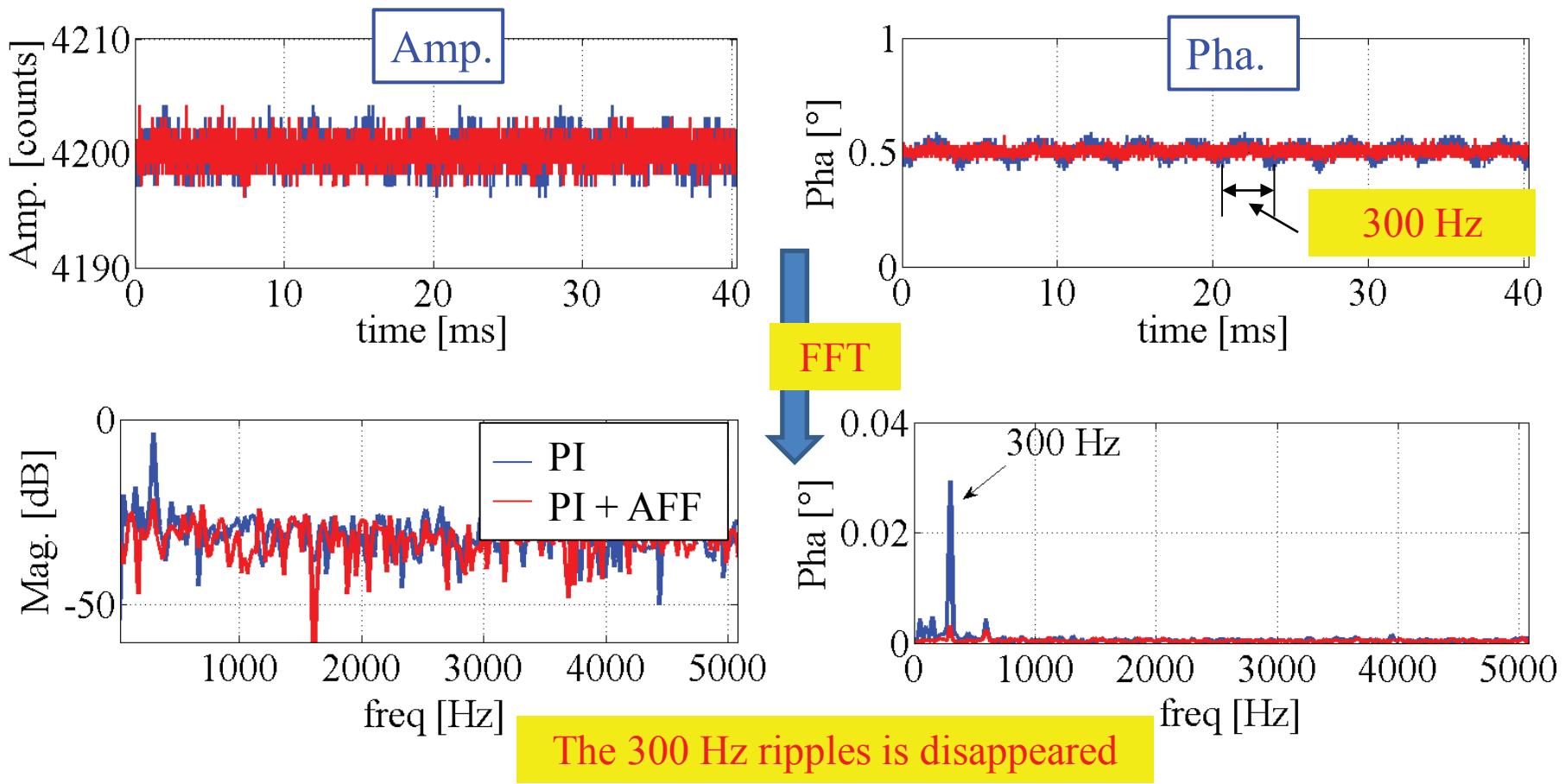
Disturbances 1 (HVPS ripples)

- Main disturbances: High voltage power supply ripples (300 Hz) + burst mode beam-loading (0.5 mA~1mA, 1 ms ~ 2 ms) and Microphonics (DC ~ 500 Hz).



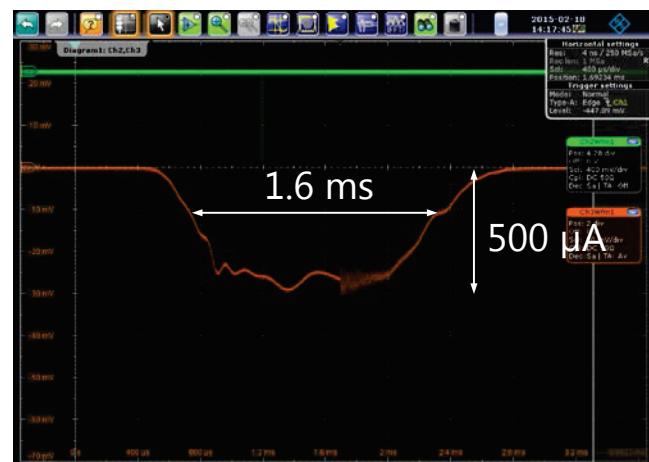
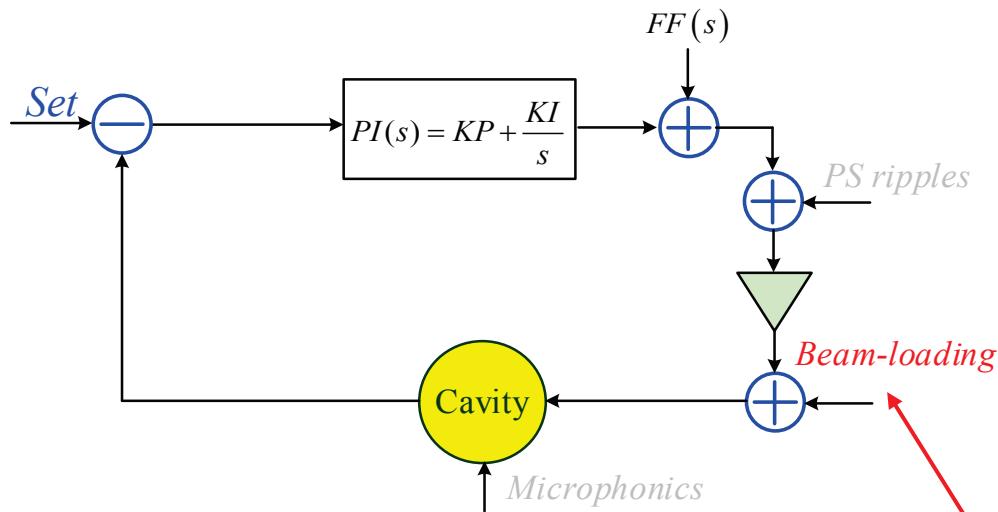
Application 1 (HVPS ripples)

- Disturbances: high voltage power supply ripples (300 Hz ripples).



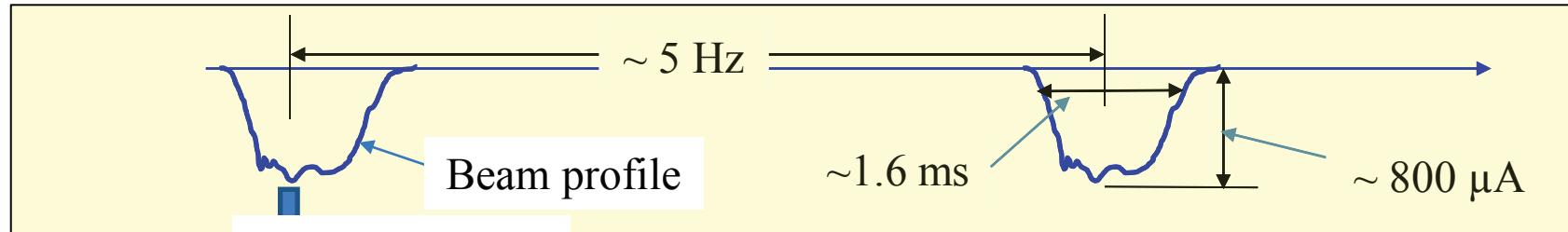
Disturbances 2 (beam-loading)

- Main disturbances: High voltage power supply ripples (300 Hz) + burst mode beam-loading (0.5 mA~1mA, 1 ms ~ 2 ms) and Microphonics (DC ~ 500 Hz).

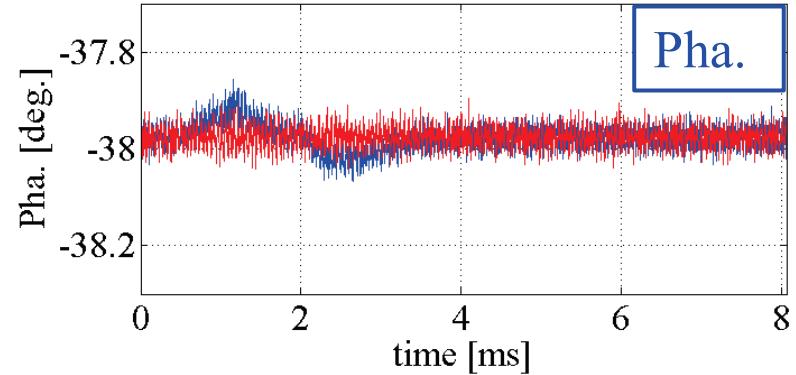
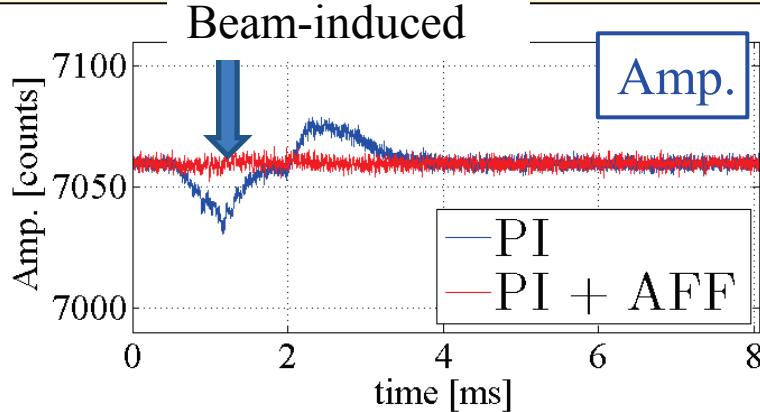


Application 2 (Beam-loading)

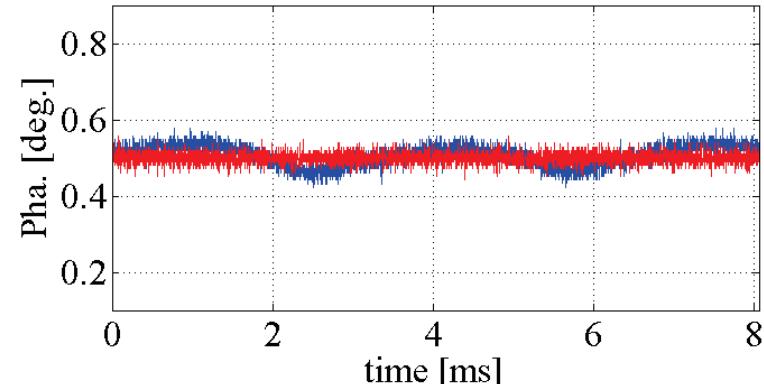
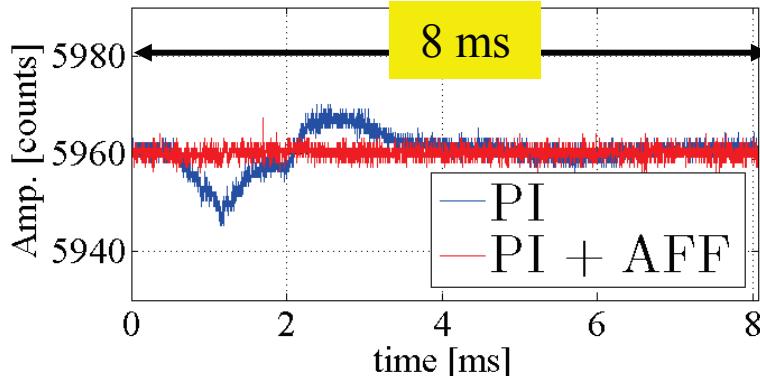
- Disturbances: Beam-loading (about 1.6 ms and 800 μ A beam current)



Inj. 1

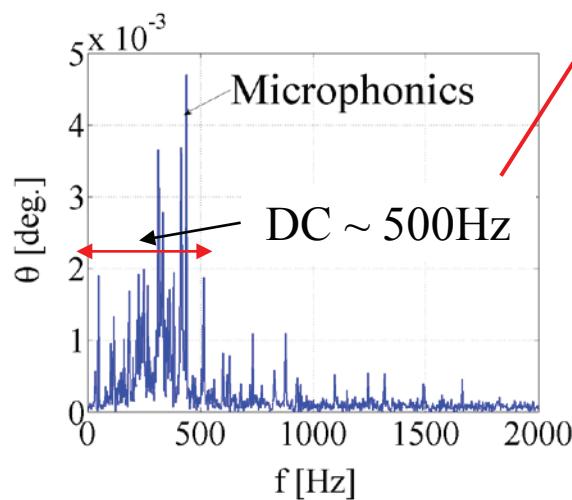
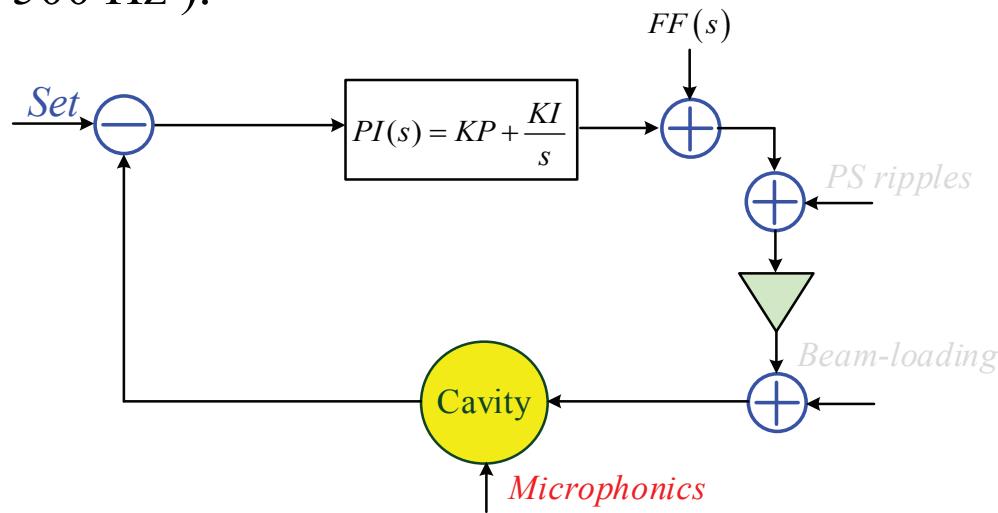


Inj. 2&3



Disturbances 3 (Microphonics)

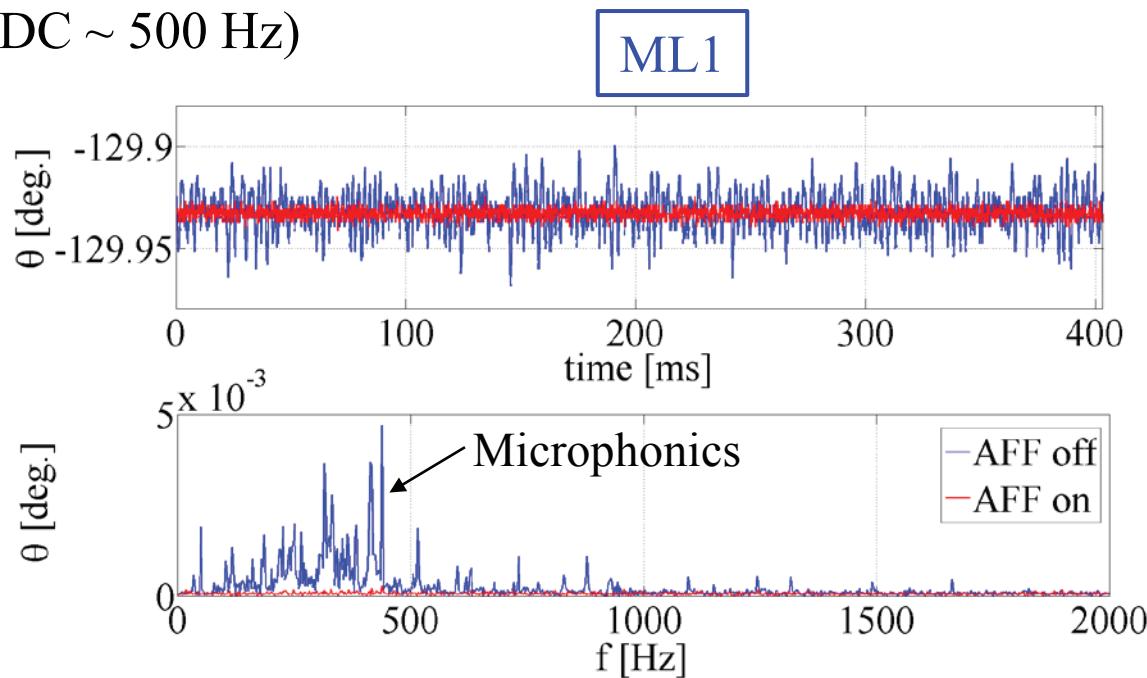
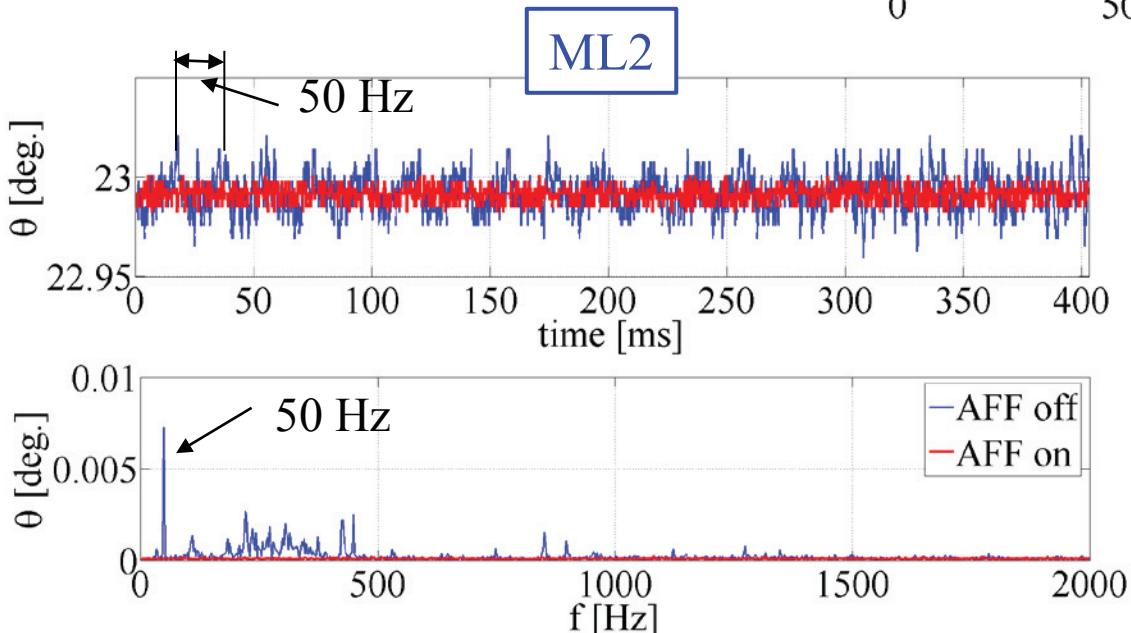
- Main disturbances: High voltage power supply ripples (300 Hz) + burst mode beam-loading (0.5 mA~1mA, 1 ms ~ 2 ms) and Microphonics (DC ~ 500 Hz).



Application 3 (Microphonics)

- Disturbances: Microphonics (DC ~ 500 Hz)

- Even with high feedback gains, the microphonics still exist in the measured RF field.



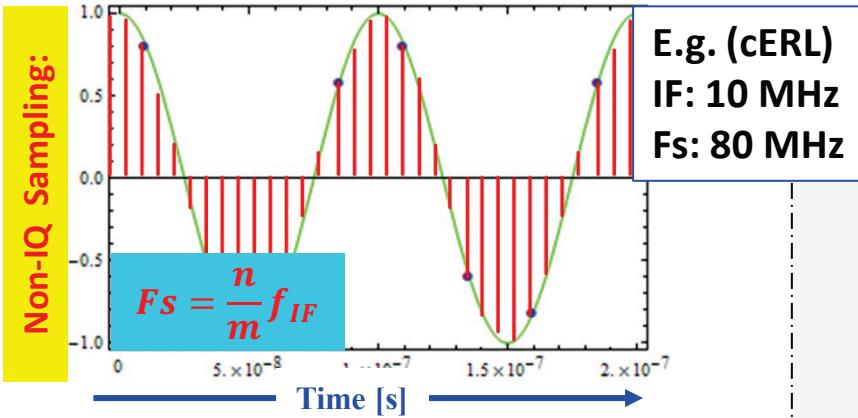
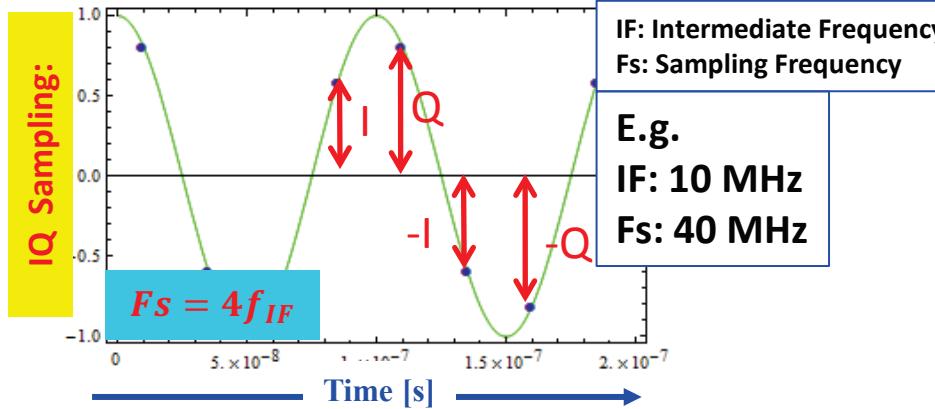
The 50 Hz component is disappeared

Summary

- Construction of the RF system for cERL was finished
- RF field requirement is satisfied.
- Very good beam momentum.
- Disturbances in RF system is rejected by a new AFF control approach

Back up

DSP algorithms (I/Q detection)

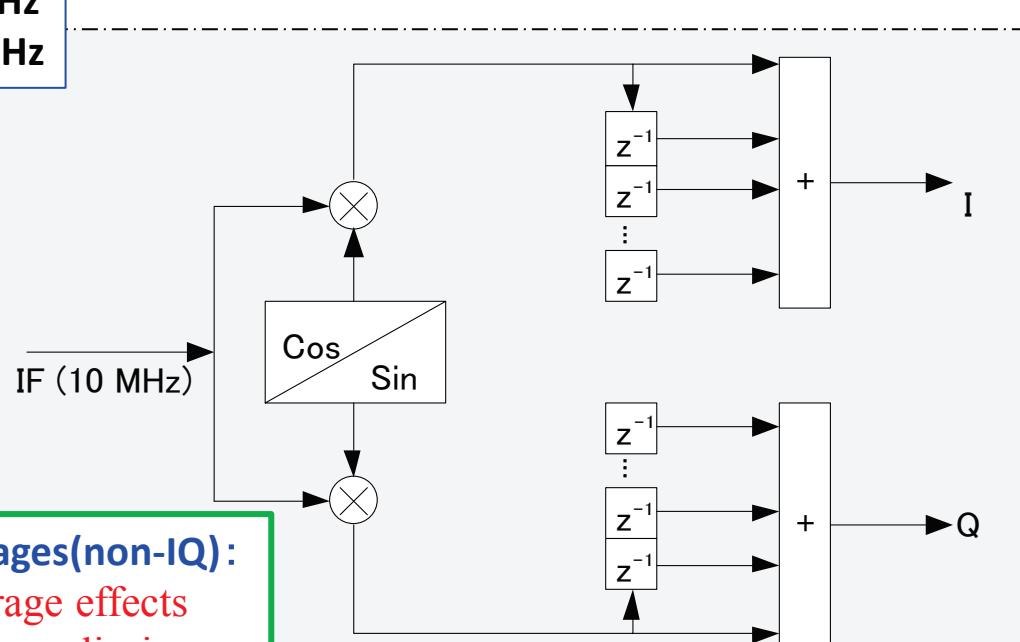
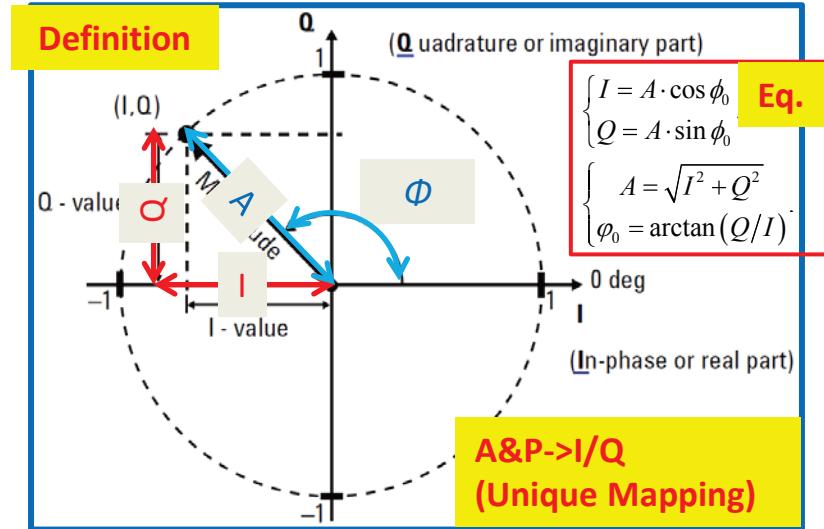


$$I = \frac{2}{8} \cdot \sum_{k=0}^7 y_i \cdot \cos\left(k \cdot \frac{2\pi}{8}\right)$$

$$Q = \frac{2}{8} \cdot \sum_{k=0}^7 y_i \cdot \sin\left(k \cdot \frac{2\pi}{8}\right)$$

Advantages(non-IQ):

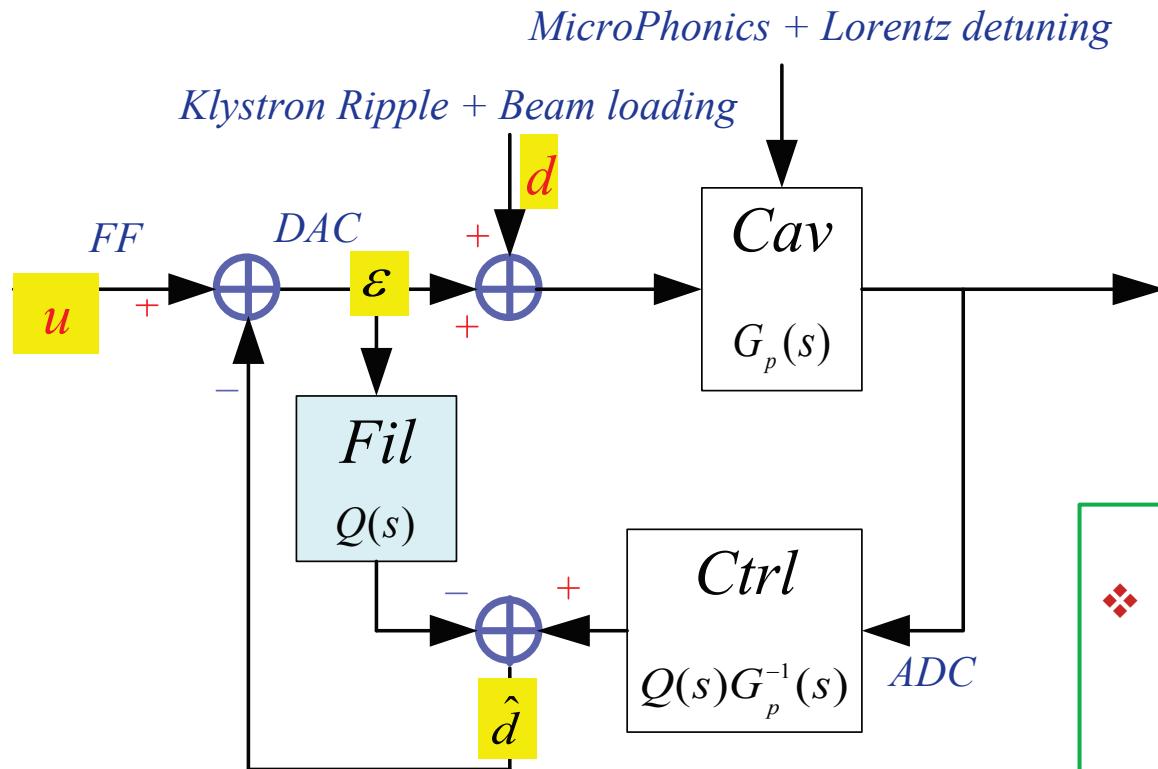
- Average effects
- Reduce aliasing



Model Based FB optimization



- The “Q” filter (LP filter) is used for improving the robustness (remove the high frequency noises)?



$$\hat{d} = (\varepsilon + d)G_p(s) \cdot G_p^{-1}(s) \cdot Q(s) - \varepsilon \cdot Q(s) = d \cdot Q(s)$$

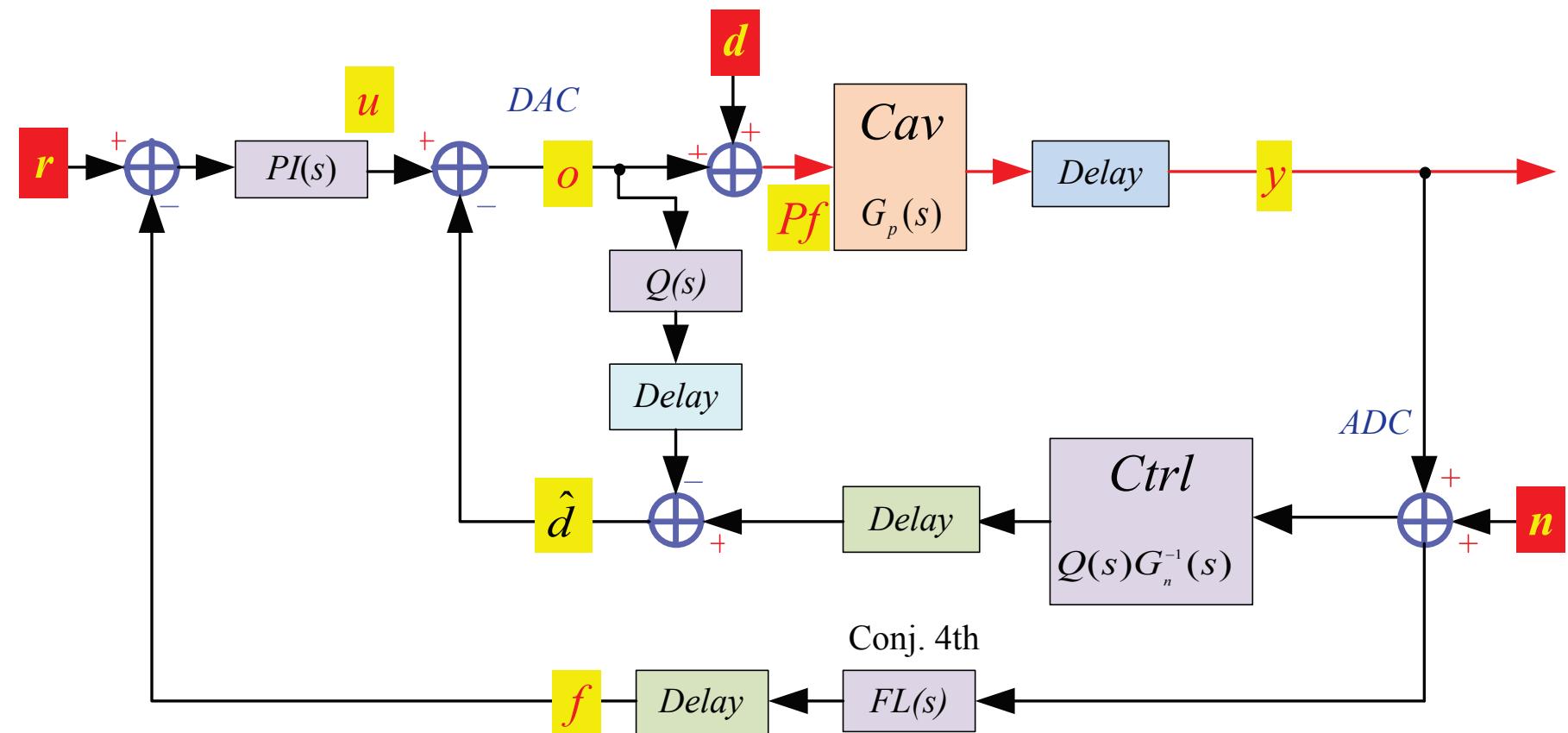
Tips

- ❖ Connected another system $Q(s)$ with $G_p^{-1}(s)$ to make sure it can be physically realized.
- ❖ If the $Q(s)$ is a low-pass filter, then the d can be still evaluated.

Total LLRF diagram



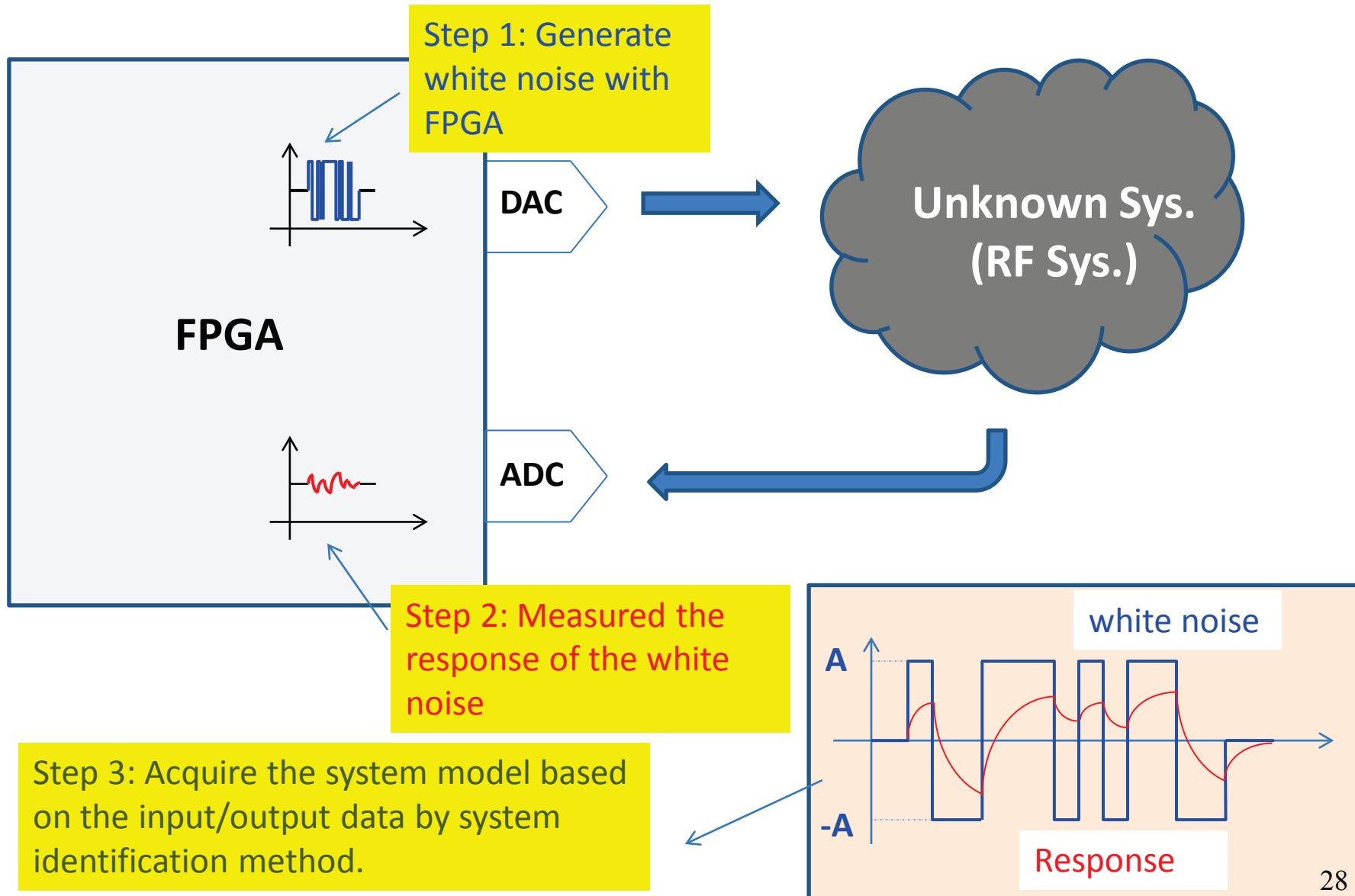
- PI + DOBC (AFF)



System Identification

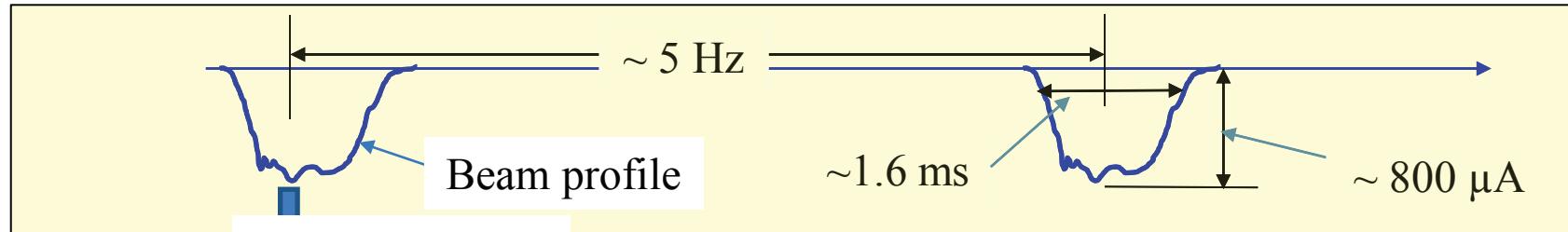


- Input white noise in the DAC output and read the response from the ADC?

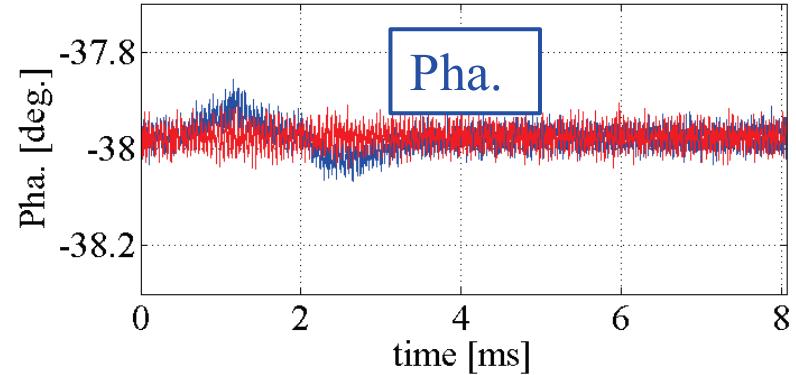
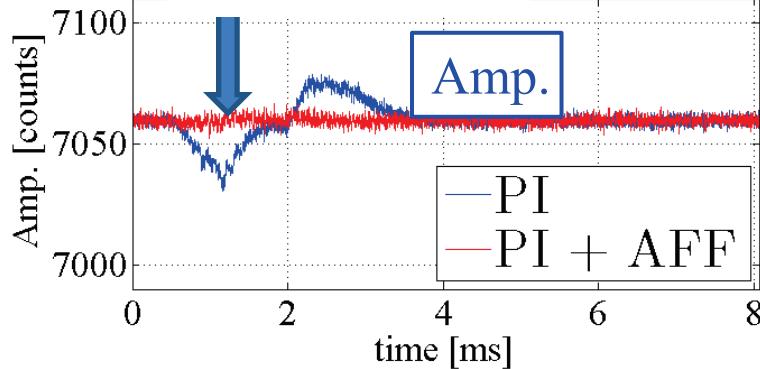


Application 2 (Beam-loading)

- Disturbances: Beam-loading (about 1.6 ms and 800 μ A beam current)



Inj. 1



Inj. 2&3

